



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Group Art Unit: 2814

Application No.: 09/423,969

Examiner: A. Mai

Filed: November 17, 1999

Docket No.: 104741

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING  
FORMATION OF BANKS

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 4, 2003 Office Action, please consider the following:

**Amendments to the Claims** are reflected in the listing of claims; and

**Remarks.**

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